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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Dalton et al.

Group Art Unit: 2812

Serial No.: 10/821,751

Examiner: Unknown

Filed: April 8, 2004

For: SURFACE TREATMENT USING IODINE PLASMA TO IMPROVE METAL DEPOSITION

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In accordance with 37 C.F.R. §1.56, the attention of the Patent and Trademark Office is directed to the cited references listed on the attached PTO/SB/08B. The cited reference is believed to be among the most relevant known to Applicants and/or Assignee at this time concerning the invention as claimed in the above-captioned patent application. No representation is made or intended that more relevant information does not exist.

Applicants respectfully request that the cited information be expressly considered during the prosecution of this application and that the cited reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom. A copy of the reference is attached.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. It is believed that no fees are due.

Respectfully submitted,

Date: July 19, 2004

Thomas Swenson  
Thomas Swenson  
Customer No. 43023

Registration No. 36,696  
Tel. No.: 303-440-7800  
Fax No.: 631-980-6001

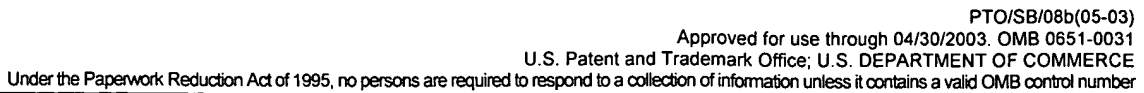
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CERTIFICATE OF MAILING (37 C.F.R. 1.8(a))

I hereby certify that, on the date shown below, this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: July 20, 2004Thomas Swenson

Thomas Swenson  
Signature



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Attorney Docket Number	101.114
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